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APPLICATION INFORMATION

Title Line One:: SUBSTRATE PROCESSING APPARATUS, SUBSTRAT
Title Line Two:: E INSPECTION METHOD AND SUBSTRATE PROCES
Title Line Three:: SING SYSTEM
Total Drawing Sheets:: 8
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: P/1250-214
Secrecy Order in Parent Appl.?: No

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-265318
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Country:: Japan
Priority Claimed:: Yes
Foreign Application Two:: 2001-209088
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